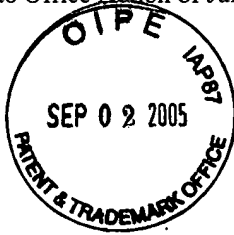


Appl. No. 10/027,935  
Amdt. dated August 31, 2005  
Reply to Office Action of June 3, 2005



Corres. and Mail  
**BOX AF**

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE\**  
**EXAMINING GROUP**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Gerard S. MOLONEY

Serial No. 10/027,935

Filed: December 21, 2001

For: APPARATUS AND METHOD  
FOR CHEMICAL-MECHANICAL  
POLISHING (CMP) HEAD  
HAVING DIRECT PNEUMATIC  
WAFER POLISHING PRESSURE

Group Art Unit: 3724

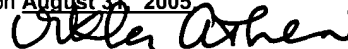
Examiner: ELEY, Timothy V.

Confirmation No.: 2631

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and its listed  
enclosures is being deposited with the United States  
Postal Service as First Class Mail addressed to  
Commissioner for Patents; P.O. Box 1450; Alexandria, VA  
22313-1450 on August 31, 2005

Signed

  
Vikki Athen

**AMENDMENT**

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is in response to the final Office Action mailed on June 3, 2005. Please amend the application as indicated below.

**Amendments to the claims** are reflected in the listing of claims which begins at page 3 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.